## Applicant(s)/Patent Under Application/Control No. Reexamination 10/609,057 LIU ET AL. Notice of References Cited Art Unit Examiner Page 1 of 1 Richard H Kim 2871 **U.S. PATENT DOCUMENTS** Document Number Country Code-Number-Kind Code Date Classification Name MM-YYYY Shigeno, Nobuyuki 349/99 US-6,147,727 11-2000 US-6,522,375 b1 02-2003 Jang et al. 349/113 В С US-6,266,111 b1 07-2001 Kataoka et al. 349/113 03-1999 349/113 D US-5,877,831 Leenhouts et al. Ε US-F US-US-G US-Н US-US-J US-K US-L US-M FOREIGN PATENT DOCUMENTS Document Number Date Country Name Classification Country Code-Number-Kind Code MM-YYYY Ν 0 Ρ Q R S Т **NON-PATENT DOCUMENTS** Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) U V W

A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.